

Amendments to the Specification

Please amend the Title as follows:

PIXELATED IMAGE SENSORS MADE FROM ORGANIC SEMICONDUCTORS

Please amend Specification as follows:

On page 35, Example 14, lines 11-20, please replace with the following paragraph.

B1  
UV and visible dual-color image elements were fabricated in the stacked structure similar to that of Example 10. The layer order from the glass substrate is as follows: ITO/6P(2000Å)/Al(300Å)/P3OT:C<sub>60</sub>(2000Å)/Au. The numbers in the brackets are the thicknesses of the corresponding layers. This sensor was connected in a circuit shown in Fig. 18 17. An Al layer was used as the common cathode of both sensors. The reading from the ITO/6P/Al sensor indicated the irradiation in the UV spectral region and the reading from the Al/P3HT/Au sensor indicated the radiation in the visible region of the spectrum. The spectral responses of these two sensors are shown in Fig. 17 18.